

PATENT

SMINT.002C3

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Granneman et al.
Appl. No. : 10/603,515
Filed : June 24, 2003
For : METHOD AND APPARATUS
FOR SUPPORTING A
SEMICONDUCTOR WAFER
DURING PROCESSING
Examiner : Unknown

Group Art Unit 2812

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October 21, 2003

(Date)

Adeel S. Akhtar

Adeel S. Akhtar, Reg. No. 41,394

REQUEST FOR CORRECTED FILING RECEIPT

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Dear Sir:

Applicants hereby request that the Official Filing Receipt be corrected to reflect the true name of the second inventor to Frank Huussen. Presently, the Filing Receipt incorrectly shows the name as Frank Hunssen. A copy of the Official Filing Receipt with the correction set forth in red ink is enclosed.

Respectfully submitted,
KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: October 21, 2003

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/603,515	06/24/2003	2812	912	ASMINT.002C3	2	29	3

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CONFIRMATION NO. 3633

FILING RECEIPT



OC000000010943662

Date Mailed: 09/29/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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 Hussen

Domestic Priority data as claimed by applicant

This application is a CON of 09/717,702 11/20/2000 PAT 6,613,685
 which is a CON of 09/227,564 01/08/1999 PAT 6,183,565
 which is a CIP of PCT/NL97/00398 07/08/1997

Foreign Applications

NETHERLANDS 1003538 07/08/1996

If Required, Foreign Filing License Granted: 09/26/2003

Projected Publication Date: 01/08/2004

Non-Publication Request: No

Early Publication Request: No

Title

Method and apparatus for supporting a semiconductor wafer during processing

Preliminary Class

438

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